Comparable to Form PTO-1449 (Rev. 5/92)	MAR 0 5 2001	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. STD 1684	Serial No. 09/723,169
			Applicant D. Sitrick	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			Filing Date November 27, 2000	Group Not Yet Assigned

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SMb		5,830,065	11/3/1998	D. Sitrick	463	31	
SMb		4,539,585	09/03/85	Spackova et al	358	93	

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
		GB 2,287,374	3/13/1995	Great Britain	H4F	U1S	X	
SMb		EP 1,033,679	9/28/1999	EPO	G06T	1/00	X	
SMb		EP 0,737,496	10/17/1994	EPO	A63F	9/22	X	
SMb		EP 0,661,658	12/20/1994	EPO	G06F	19/00	X	
SMb		ES 2,077,524	12/2/1993	Spain	A63F	9/22		X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SMb		Beier, Thaddeus et al., "Feature-Based Image Metamorphosis," Computer Graphics Proceedings of The Association for Computing Machinery's Special Interest Group on Computer Graphics, Vol. 26, No. 2, pp.35-42.
SMb		Hughes, John F., "Scheduled Fourier Volume Morphing," Computer Graphics Proceedings of The Association for Computing Machinery's Special Interest Group on Computer Graphics, Vol. 26, No. 2, pp. 43-46.
SMb		Kent, James R. et. al., "Shape Transformation for Polyhedral Objects," Computer Graphics Proceedings of The Association for Computing Machinery's Special Interest Group on Computer Graphics, Vol. 26, No. 2, pp. 47-54.

Examiner	Date Considered 5/29/03

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Comparable to Form PTO-1449 (Rev. 5/92)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. STD/1684	Serial No 09/723,169

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant D. Sitrick	
	Filing Date November 27, 2000	Group Not Yet Assigned

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
5 Mp		EP 0, 402,067	06/01/90	EPO				
5 Mp		EP 0 092 075	03/30/83	EPO				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

5 Mp		Okabe, Hidehiko, et. al., "Three Dimensional Apparel CAD System," Computer Graphics Proceedings of The Association for Computing Machinery's Special Interest Group on Computer Graphics, Vol. 26, No. 2, pp. 105-110.
5 Mp		Sederberg et.al., "A Physically Based Approach to 2-D Shape Blending,"Computer Graphics Proceedings of The Association for Computing Machinery's Special Interest Group on Computer Graphics, Vol. 26, No. 2, July 1992, pp. 25-34.
5 Mp		Ultimatte Overview, Ultimatte Corporation, Chatsworth, California, Copyright 1990 to 1996, pp. 1-20.

Examiner	Date Considered 5/28/02

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Comparable to Form PTO-1449 (Rev. 5/92)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. STD 1684	Serial No. 09/723,169

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant D. Sitrick

	Filing Date November 27, 2000	Group Not Yet Assigned

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Smf		Vaz, Mark Cotta et. al., Industrial Light & Magic: Into the Digital Realm, Ballantine Books, New York 1996, pp. 219-272.

Examiner	Date Considered 5/27/03

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.